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Docket No.: 2328-050A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	EXPEDITED PROCEDURE
Jian J. CHEN et al.	:	Response under 37 CFR 1.116
	:	Confirmation No. 3505
	:	
U.S. Patent Application No. 10/647,347	:	Group Art Unit: 1763
	:	
Filed: August 26, 2003	:	Examiner: LUZ L ALEJANDRO
For: INDUCTIVE PLASMA PROCESSOR METHOD		

AMENDMENT UNDER RULE 116

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

May 9, 2005

Sir:

This paper is submitted in reply to the Office Action mailed March 9, 2005, which was made Final. Applicants respectfully request that the following amendments **as to form** be entered to place this application in condition for allowance.